

312-102

- 1 -

Docket No. 0756-958

3214  
9-4-96  
C. Brown



CERTIFICATE OF MAILING

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Deborah T. Tomme  
Deborah T. Tomme

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

RECEIVED

Shunpei YAMAZAKI et al.

AUG 23 1996

Serial No. 08/183,800

) Examiner Saeki

Filed: January 21, 1994

) Art Unit: 2508

For: SEMICONDUCTOR MATERIAL

)

AND METHOD FOR FORMING

)

THE SAME AND THIN FILM

)

TRANSISTOR

) August 5, 1996

GROUP 2500

AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action mailed March 5, 1996, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 23-35 as follows:

23. (Three Times Amended) A thin film transistor comprising:  
[an intrinsic channel] a semiconductor layer having an intrinsic  
or substantially intrinsic channel region;

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